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Docket: 0819-548

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of )  
Mitsuru TANABE )  
Japanese Priority Application No. 2000-119604 ) Attn: Applications  
Japanese Priority Date: April 20, 2000 ) Branch  
For: MICROSTRIP LINE, METHOD FOR )  
FABRICATING THE SAME, INDUCTOR )  
ELEMENT, AND RF SEMICONDUCTOR )  
DEVICE ) Date: April 20, 2001

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents  
Washington, D.C. 20231


Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,

  
Eric J. Robinson  
Registration No. 38,285

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 790-9110